



IPW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE.

In re the Application of

Shinichi FUKADA

Group Art Unit: 2811

Application No.: 10/849,016

Examiner: S. GEBREMARIAM

Filed: May 20, 2004

Docket No.: 119798

For: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the May 5, 2005, Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims;

Amendments to the Drawings include an attached replacement sheet; and

Remarks.